



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shinji NAKAMURA et al.

Application No. 09/680,054

Filed: October 5, 2000

For: SEMICONDUCTOR DEVICE,
SEMICONDUCTOR SUBSTRATE,
AND MANUFACTURE METHOD

)

) Group Art Unit: 2823

) Examiner: Brook Kebede

) Confirmation No. 7323

) Date: March 3, 2004

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CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

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Signature: _____

Name: Deborah Movahhedi

AMENDMENT

Mail Stop **BOX AF**
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Sir:

In response to the Office Action dated December 3, 2003, please amend the above identified application as follows.

3/10/04
Bn
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